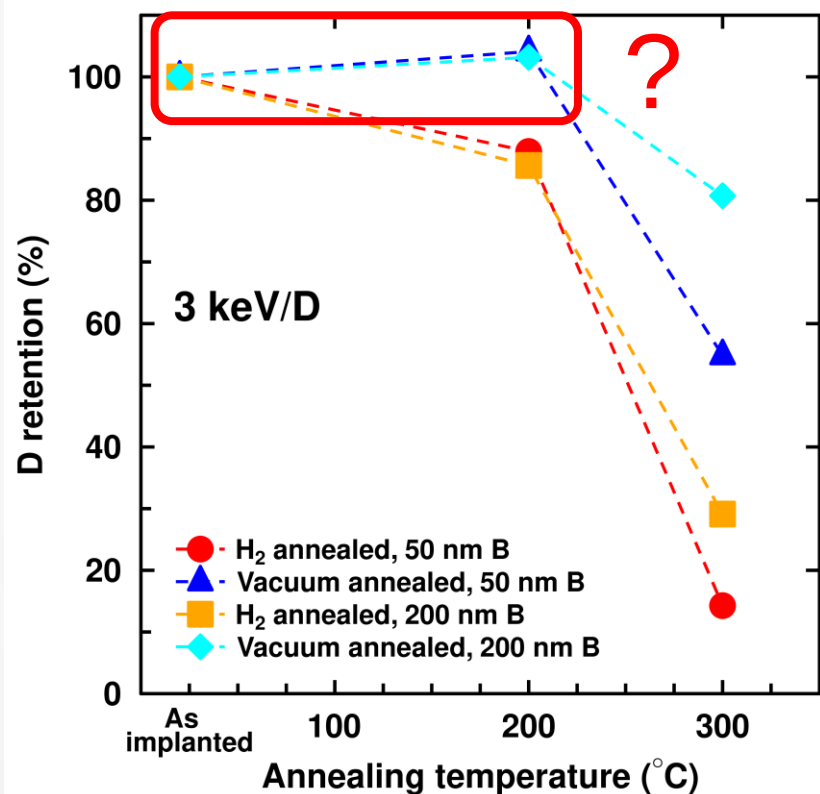




DEUTERIUM RETENTION IN BORON AFTER VACUUM ANNEALING: ERDA RESULTS

1. MS: 50 nm and 200 nm pure B film on W at 300 C
2. 3 keV/D ion implantation
3. Annealing of samples



50 nm B
on W
+ 3 keV/D

200 nm B
on W
+ 3 keV/D

